

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Kimio HAGI

Serial No.:

Group Art Unit:

Filed: December 11, 2000

Examiner:

For: ELECTROSTATIC CHUCKING SYSTEM, AND APPARATUS AND METHOD OF
MANUFACTURING A SEMICONDUCTOR DEVICE USING THE ELECTROSTATIC
CHUCKING SYSTEMJC490 U.S. PRO
09/732,891
12/11/00INFORMATION DISCLOSURE STATEMENTAssistant Commissioner for Patents
Washington, DC 2023142
105
Chikara
10/10/01

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The non-English reference is accompanied by an English abstract.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Stephen A. Becker
Registration No. 26,527

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 SAB:dtb
Date: December 11, 2000
Facsimile: (202) 756-8087